

Search Notes

Application/Control No.

10/779,400

Examiner

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Applicant(s)/Patent under
Reexamination

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Art Unit

2111

SEARCHED

Class	Subclass	Date	Examiner
710	305-315, 58-64, 8-19	9/14/2006	RP
709	201-203	9/14/2006	RP

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
710	305,307	9/19/2006	RP
710	61,310	9/19/2006	RP

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR